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**CONFIRMATION NO. 4433** 

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<b>SERIAL NUMBE</b> I 09/769,832	FILING DATE 01/26/2001 RULE	CLASS 430 35 5	GROUP AR 1756		ATTORNEY DOCKET NO. 108455
Naomasa Sh	ura, Tokyo, JAPAN; iraishi, Urawa-shi, JAPAN Tokyo, JAPAN;	•			
FOREIGN APPL JAPAN 2000 JAPAN 2000				٠.	
	ns Lygg no Met after  Allowshop  Examiner's Signature (nit)	JAPAN	SHEETS DRAWING 19	TOTAL CLAIM: 66	- p
ADDRESS 25944					
TITLE Projection exposure	apparatus and method, ca	atadioptric optical syst	em and manuf	acturing m	ethod of devices
RECEIVED No.	ES: Authority has been given to charge/crefor for following:	□ 1.1 time) □ 1.1 □ 0th	All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue.)  Other  Credit		